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PATENT APPLICATION

AF#

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2813.
2818

In re the Application of

Kiyoichi SUWA

Group Art Unit: 2818

Application No.: 09/729,339

Examiner: Q. Hoang

Filed: December 5, 2000

Docket No.: 108057

For: MASK, EXPOSURE METHOD, LINE WIDTH MEASURING METHOD, AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICES

**NOTICE OF APPEAL TO THE BOARD OF
PATENT APPEALS AND INTERFERENCES**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the Decision of the
Primary Examiner dated August 27, 2003.

The \$330.00 Appeal Fee (\$165.00 Small Entity) is:

 X Enclosed (our Check No. 151539)

 Not required (fee paid in prior appeal in this
application with no Board Decision on the merits).

This Notice of Appeal is filed to maintain this application pending. The Amendment After Final
Rejection and Petition for (3 month) Extension of Time filed February 17, 2004 should place this
application in condition for allowance.

The Commissioner is hereby authorized to charge any fees which may be required or credit any
overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

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330.00 OP

MAC/ccs

Date: February 27, 2004

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Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;

Charge any fee due to our
Deposit Account No. 15-0461